



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

THOMAS SONDERMAN
SCOTT BUSHMAN
CRAIG WILLIAM CHRISTIAN

Serial No.: 09/851,905

Filed: MAY 09, 2001

For: RUN-TO-RUN CONTROL METHOD FOR
AUTOMATED CONTROL OF METAL
DEPOSITION PROCESSES

Group Art Unit: 2125

Examiner: R. Jarrett

Conf. No.: 3951

Atty. Dkt.: 2000.044700/TT3229

RECEIVED

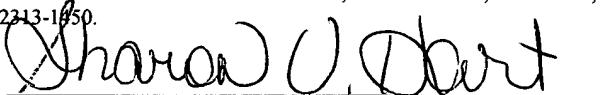
MAY 08 2003

Technology Center 2100

RESPONSE TO OFFICE ACTION MAILED FEBRUARY 04, 2003

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING UNDER C.F.R. § 1.8	
DATE OF DEPOSIT:	May 1, 2003
I hereby certify that this paper or fee is being deposited with the United States Postal Service with sufficient postage as "FIRST CLASS MAIL" addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
 Signature	

This paper is submitted in response to the Office Action mailed February 04, 2003, for which the shortened three-month statutory response date is May 04, 2003. Since this response is being filed on May 01, 2003, this paper is timely filed.

No fee is believed due as a result of the response contained herein. However, **should any fees under 37 C.F.R. §§ 1.16 to 1.21 be required for any reason, the Commissioner is authorized to deduct said fees from Advanced Micro Devices, Inc. Deposit Account No. 01-0365/TT3229.** In the event the monies in that account are insufficient, the Commissioner is authorized to withdraw funds from Williams, Morgan & Amerson, P.C. Deposit Account No. 50-0786/2000.044700.